

2018 CHLN Multi-State Annual Meeting Agenda

CHLN Multi-State Annual Meeting

Wednesday, May 30

LOCATION: Campus Center XXX, University of Hawai'i at Mānoa

Registration Fee: \$TBD

- 8:30 am Welcome, Introductions, Agenda Review
- 9:00 am Review CHLN Project Overview, Background, Project Importance, Goals, Objectives, Google Drive Folder, and Leadership Roles
<https://www.nimss.org/projects/view/mrp/outline/18097>
<https://drive.google.com/drive/folders/OBzl7auVLNH000GZoakh5MXV6bU0?usp=sharing>
- 9:45 am Review CHLN Guidelines and Expectations & Vote to Confirm Changes
- 10:30 am Morning Break
- 10:45 am Monitoring Sub-Group Updates
- 11:00 am Training Sub-Group Updates
- 11:15 am Research Sub-Group Updates
- 11:30 am Extension & Policy Sub-Group Updates
- 11:45 am Lunch & Walk Outside
- 1:30 pm Working Meeting: Re-Visit Monitoring Sub Group Work Plan
- 2:00 pm Working Meeting: Monitoring De-brief & Action Items
- 2:10 pm Working Meeting: Re-Visit Training Sub Group Work Plan
- 2:40 pm Working Meeting: Training De-brief & Action Items
- 2:50 pm Working Meeting: Re-Visit Research Sub Group Work Plan
- 3:20 pm Working Meeting: Research De-brief & Action Items
- 3:30 pm Working Meeting: Re-Visit Extension & Policy Sub Group Work Plan
- 4:00 pm Working Meeting: Extension & Policy De-brief & Action Items
- 4:10 pm Closing Reflections & Wrap Up (+/Delta)
- 4:30 pm Adjourn

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Thursday, May 31

LOCATION: Campus Center XXX, University of Hawai'i at Mānoa

Registration Fee: \$TBD

- 8:30 am Reflections from Wednesday, May 30 & Agenda Review
- 9:00 am Establish 2018 – 2019 CHLN Timeline (Including Annual Meeting Date) & Objectives/Goals
- 10:30 am Morning Break
- 10:45 am Preparations for CHLN Annual Report & Discussion on 2018 Impacts
- 11:30 am Lunch & Walk Outside
- 1:00 pm Meeting Reflection & Wrap Up (+/Delta)
- 1:15 pm Optional Training Session: R Project for Statistical Computing
<https://www.r-project.org/>
- 4:30 pm Adjourn